

PATENT  
0020-5123P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Shinichi NAGAHAMA et al. Conf.: 8194

Appl. No.: 10/601,582 Group: 2815

Filed: June 24, 2003 Examiner: A. WILSON

For: NITRIDE SEMICONDUCTOR DEVICE

COMMENTS ON EXAMINER'S STATEMENT  
OF REASONS FOR ALLOWANCE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 15, 2004

Sir:

Applicants note with appreciation the allowance of claims 46-65 of the above-identified application. It is respectfully noted, however, that the Statement of Reasons for Allowance merely paraphrases, to a substantial extent, the limitations actually recited in the claims. It is respectfully noted that the claims stand upon their own recitations, and limitations should not be imputed to the claims based upon the Statement of Reasons for Allowance.

Should there be any outstanding matters that need to be resolved in the present application, the Examiner is respectfully requested to contact Catherine M. Voisinet (Reg. No. 52,327) at the telephone number below.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

  
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